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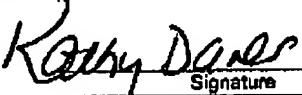
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
 Thomas Sonderman, et al
 Serial No.: 09/751,083
 Filed: December 29, 2000
 For: METHOD AND APPARATUS FOR
 CONTROLLING WAFER THICKNESS
 UNIFORMITY IN A MULTI-ZONE
 VERTICAL FURNACE

Examiner: R. FULLER
 Group Art Unit: 2851
 Att'y Docket: 2000.044400

RESPONSE TO OFFICE ACTION DATED MARCH 26, 2004

CERTIFICATE OF TRANSMISSION 37 C.F.R 1.6D	
I hereby certify that this correspondence is being transmitted by facsimile to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 at 1-703-872-9306 on the date below:	
<u>9.23.04</u> Date	 Signature

Commissioner for Patents
 P.O. Box 1450
 Alexandria, Va. 22313-1450

Sir:

This paper is submitted in response to the Office Action dated March 26, 2004, for which the six-month date for response is Monday, September 27, 2004. Applicants hereby petition for a three-month extension of time to reply.

It is believed that a fee of \$950.00 is due for the extension of time; the Commissioner is hereby authorized to deduct the extension fees from Williams, Morgan & Amerson's P.C. Deposit Account No. 50-0786/2000.044400. Should additional fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason, the Commissioner is authorized to deduct said fees from Williams, Morgan & Amerson's P.C. Deposit Account No. 50-0786/2000.044400.

Reconsideration of the application is respectfully requested.

Serial No. 09/751,083